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Biography

Miss Rutchaneekom Ruamthawee was born on the 10th of January in 1976. She was born in Bangkok. In 1997, she attained a Bachelor Degree in Material science from Faculty of Science, Chulalongkorn University. She continued a further study in Master Degree in the field of Ceramic Technology at the same place in June 1997 and completed all of programs in March 1999.



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